

# Search Notes



Application/Control No.

10/687,424

Examiner

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Applicant(s)/Patent under Reexamination

LIAW, JHON JHY

Art Unit

1765

## SEARCHED

Class	Subclass	Date	Examiner
438	700	5/12/2005	K-cc
	702		
	703		
	706		
	710		
	714		
	719		
438	724	5/12/05	K-cc
updated		9/1/05	K-cc
updated		5/22/06	Kcc

## INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner
438	700	5/24/06	Kcc
	702		
	703		
	706		
	710		
	714		
	719		
438	724	5/24/06	Kcc

## SEARCH NOTES (INCLUDING SEARCH STRATEGY)

	DATE	EXMR
EAST key words search, USPAT, US-PGPUB, EPO, JPO, Derwent, IBM-TDB, inventor search.	5/12/2005	K-cc
updated	9/1/05	K-cc
updated	5/22/06	Kcc